

Supplementary Information for

Three-dimensional Spirals of Atomic Layered MoS₂

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S1—CVD Synthesis of MoS₂ spiral

S2—Structural characterization of spirals using X-ray diffraction (XRD)

S3—Morphology characterization of one large spiral by atomic force microscopy (AFM)

S4—Composition study of spiral by X-ray photoelectron spectroscopy (XPS)

S5—Stability of different configurations in AA-stacked bilayer MoS₂

S6—Band structure of AA-stacked MoS₂

S1: CVD Synthesis of MoS₂ spiral.

We grew MoS₂ spirals by CVD using MoO₃ and S as precursors. The substrate was loaded into the 1-inch CVD furnace and placed face-down above one crucible containing 5.0~7.5 mg of MoO₃ ($\geq 99.5\%$, sigma-Aldrich) with another crucible containing 140 mg of S ($\geq 99.5\%$, sigma-Aldrich). In order to increase the possibility to get spirals, S was loaded in the high temperature region close to MoO₃. In contrast, for monolayer growth, the substrate was loaded above one crucible containing 20 mg of MoO₃ together with another crucible containing 6.5~7.0 mg of S and the distance between S and MoO₃ is about 12 cm. MoS₂ spirals could be directly grown on diverse substrates (Fig. S1) and the optimized parameters have been summarized in Table 1.

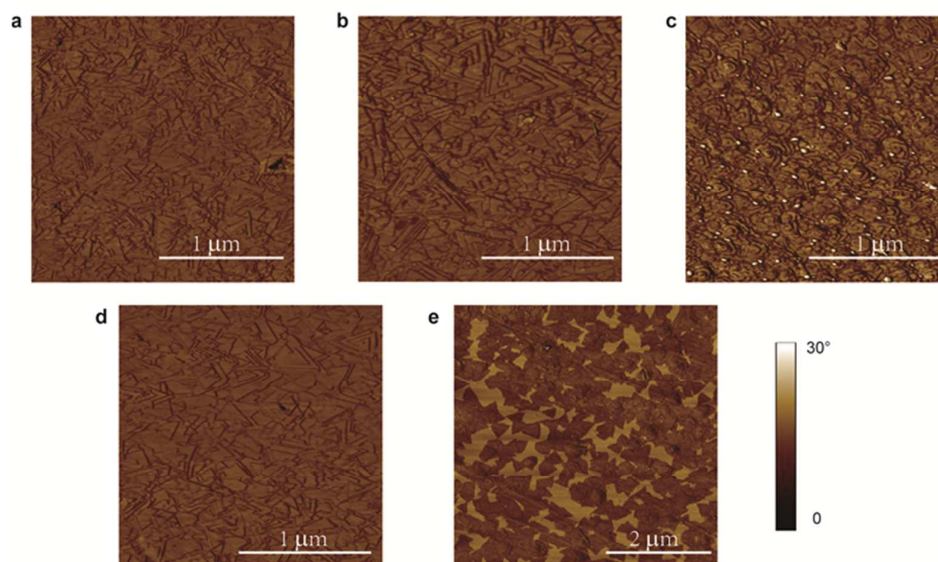


Fig. S1 a-e, CVD synthesis of MoS₂ spiral on varied substrates (a) Si, (b) mica, (c) SiO₂, (d) TiO₂ and (e) fused silica.

Table S1 Detail synthesis parameters for MoS₂ spiral

Substrate	Source temperature (°C)	Mass ratio between MoO ₃ and S	Carrier gas flow rate (sccm)	Growth temperature (°C)	Growth time (min)	Pressure (Torr)	Domain size
Si	MoO ₃ : 650-700 S: 600-650	MoO ₃ /S 5.0~7.5 mg/140 mg	ultrahigh-purity N ₂ 10-15 sccm	700	5-20	ambient pressure	300-350 nm
SiNWs							
TiO ₂							
SiO ₂							
Fused silica							
Mica	MoO ₃ : 600-650 S: 550-600			650			
Fused silica	MoO ₃ : 650-700 S: 450-500	MoO ₃ /S 20 mg/6.5-7.0 mg		700			> 10 μm

S2: Structural characterization of spirals using XRD.

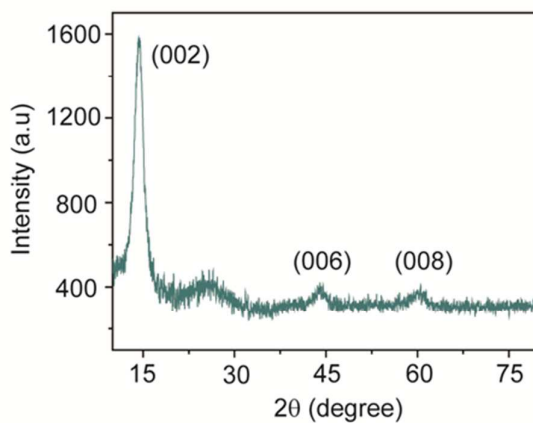


Fig. S2 XRD patterns of MoS₂ spirals. A pronounced diffraction peak locates at 14.4°, which corresponds to (002) crystal planes in Z direction. The wide peak signal between 20° and 30° originates from the fused silica substrate.

S3: Morphology characterization of one large MoS₂ spiral by AFM.

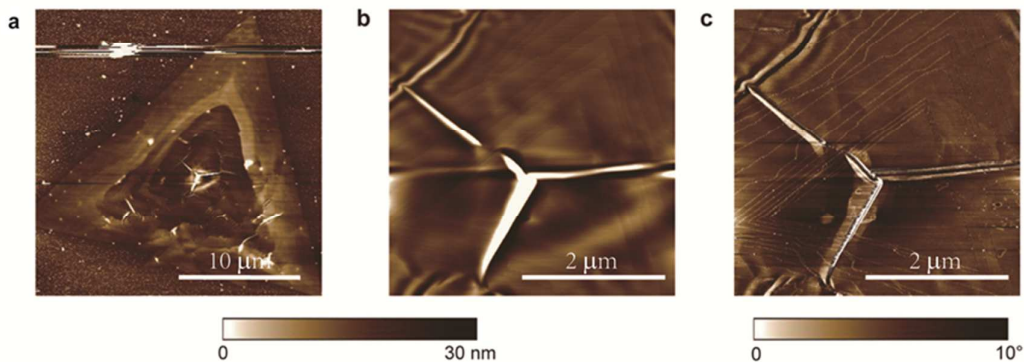


Fig. S3 a-c, Low- (a, height signal) and high- (b, height signal; c, phase signal) magnification AFM images of one large MoS₂ spiral with edge length ~20 μm. The wrinkles formed in the center were attributed to the topological deformation resulted in the process of temperature decreasing.

S4: Composition study of spirals by XPS.

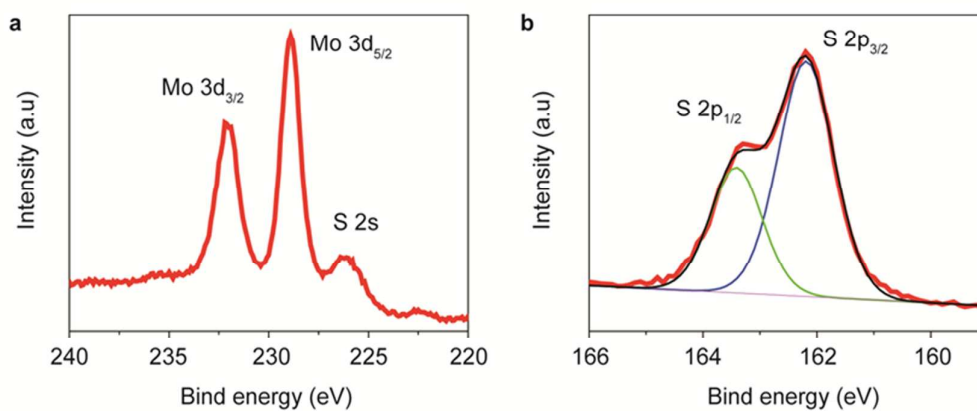


Fig. S4 a-b, High-resolution XPS spectra of Mo 3d, S 2s (a) and S 2p (b) peaks.

S5: Stability of different configurations in AA-stacked bilayer MoS₂.

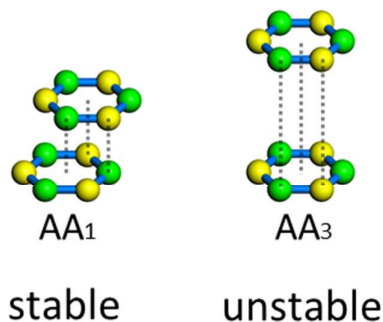


Fig. S5 Configuration of highly symmetric structures of AA stacked bilayer MoS₂. Local-density approximation (LDA) calculation shows that AA₁ is energetically stable, while AA₃ is unstable.

S6: LDA Band structure of AA-stacked MoS₂.

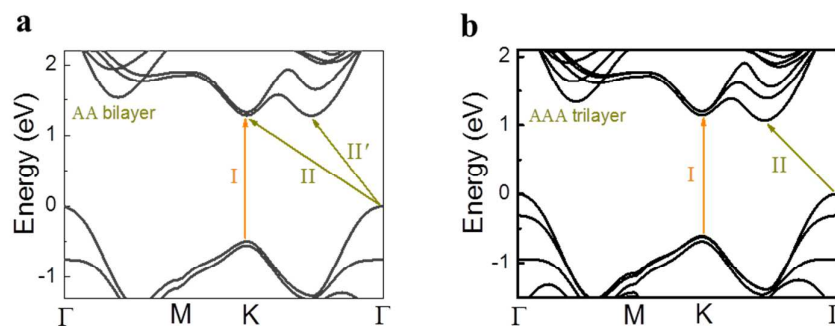


Fig. S6 a-b, LDA band structure of AA-stacked bilayer (a) and trilayer (b) MoS₂. The transition I corresponds to the main PL peak around 1.8 eV in the PL spectra, while transition II (or II') corresponds to the indirect photoemission. A supercell arrangement was used in the calculation, with the vacuum thickness set at 10 Å to avoid interactions between the MoS₂ bilayer/trilayer and its periodic images. We employ norm-conserving pseudo-potentials with a plane-wave energy cutoff of 140 Ry. The structures were fully relaxed until the force on each atom is smaller than 0.01 eV/Å. Spin-orbit coupling was not included in our calculations.